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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Lawrence S. Fischer et al.

Group Art Unit: 1753

Serial No.: 10/604,272

Examiner: Unknown

Filed: 07/08/2003

For: SAMPLE MOUNT FOR PERFORMING SPUTTER-DEPOSITION IN A FOCUSED ION
BEAM (FIB) TOOL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF FORMAL DRAWINGS

Sir:

Submitted herewith are two (2) sheets of formal drawings comprising Figs. 1-2 for the
above-referenced patent application. Acknowledgment of receipt is respectfully requested. Please
substitute these formal drawings for the drawings which were filed with the application.

Respectfully Submitted,

Frederick W. Gibb, III
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s):

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Examiner

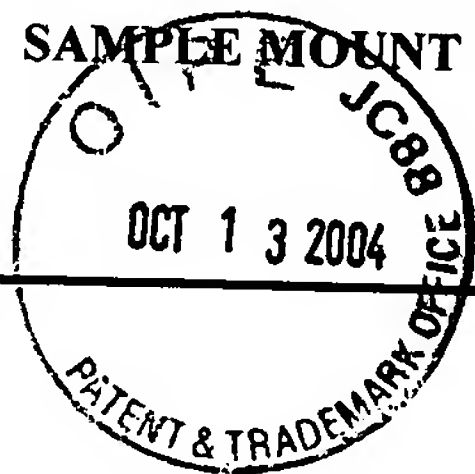
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Customer No.

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Group Art Unit

1753

Invention: **SAMPLE MOUNT FOR PERFORMING SPUTTER-DEPOSITION IN A FOCUSED ION BEAM (FIB)**
TOOL

I hereby certify that this

Submission of Formal Drawings*(Identify type of correspondence)*

is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Director of the United States Patent and Trademark Office, P.O. Box 1450, Alexandria, VA

22313-1450" [37 CFR 1.8(a)] on

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*(Date)*Frederick W. Gibb, III*(Typed or Printed Name of Person Mailing Correspondence)**(Signature of Person Mailing Correspondence)*

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